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Bib Data Sheet

CONFIRMATION NO. 2798

SERIAL NUMBER 10/779,397 FILING OR 371 DATE 02/13/2004 RULE		02/13/2004	CLASS 134		GROUP ART UNIT 1746		ATTORNEY DOCKET NO. 199372003910		
APPLICANTS Naoki Shindo, Nirasaki-shi, JAPAN; Tadashi Iino, Nirasaki-shi, JAPAN; *** CONTINUING DATA ********************** This application is a DIV of 10/034,520 12/28/2001 PAT 6,729,041 *** FOREIGN APPLICATIONS ************************************									
** 01/06/2005 Foreign Priority claimed				STATE OR COUNTRY JAPAN	SHEETS DRAWING 18		TOTA CLAI 7		INDEPENDENT CLAIMS 2
TITLE Substrate processing apparatus and substrate processing method									
RECEIVED	۷o	EES: Authority has been given in Paper o to charge/credit DEPOSIT ACCOUNT o for following:				☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) ☐ 1.18 Fees (Issue) ☐ Other ☐ Credit			